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ATTY DOCKET NO. COLB-124XX	SERIAL NUMBER 10/673,996
APPLICANT Tzachi RAFAELI, et al.	EXAMINER
FILING DATE September 29, 2003	GROUP ART UNIT 2882
	APPLICANT Tzachi RAFAELI, et al. FILING DATE

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Date: February 4, 2004 Page 2 of 2 FORM PTO-1449 ATTY DOCKET NO. FEB 0 9 2004 SERIAL NUMBER COLB-124XX 10/673,996 LIST OF PATENTS AND REPUBLICATIONS FOR APPLICANTS' **APPLICANT EXAMINER** Tzachi RAFAELI, et al. INFORMATION STATEMENT FILING DATE GROUP ART UNIT September 29, 2003 2882

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